Docket No.

DECLARATION AND POWER OF ATTROENY

As a below named inventor, I hereby declare that:

My residence, post office and citizenship are as stated below next to my name,

I believe I am th	ne original, first a	and sole inventor (if only	one name is lis	ted below) or an	original, first and
joint inventor (if	plural names a	re listed below) of the	subject matter o	laimed and for	which a patent is
sought on the	invention ent	itled PROCESS F	OR LAPPING	WAFER AND	METHOD FOR
PROCESSING	BACKSIDE OF \	NAFER USING THE SA	ME		
the specification	of which				
[X]is attached h	ereto []was fi	led on	_ as Application	Serial No	
and was amend	led on	(if applicable)			
I hereby state	that I have revi	ewed and understand t	he contents of	the above ident	tified specification
including the cla	aims as amende	d by any amendment ref	erred to above.		
l acknowledge	the duty to disc	lose information which	is known to me	to be material	to patentability in
E-17		of Federal Regulations,			,
l hereby claim	foreian priority b	enefits under Title 35, l	Inited States Co	nde Section 119	a)-(d) or Section
4 1		on(s) for patent or inve		•	. , . ,
48	- , .	designated at least one		•	•
Seate.	-	any foreign application fo	•		•
5 में		which priority is claimed			
Prior Foreign A	pplication(s):		Priority Claime	d	
Number	Country	Day/Month/Year Filed	<u>Yes</u>	<u>No</u>	
2001-54519	Korea	05/September/2001	XX		
I hereby claim below.	the benefit und	er 35 USC §119(e) of	any United Stat	es provisional a	pplication(s) listed
Prior Provision	al Application(s)				
Application Nu	mber	Filing Date			

I hereby claim the benefit under Title 35, United States Code, Section 120 of any United States application(s), or Section 365(c) of any PCT international application designating the United States, listed below and insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT international application in the manner provided by the first paragraph of Title 35, United States Code, Section 112, I acknowledge the duty to disclose material information as defined in Title

37, code of Federal Regulations, Section 1.56 which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

Prior U. S. Application(s)

Serial No.

Filing Date

Status: Patented Pending. Abandoned

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

I hereby appoint the following attorney(s) and/or agent(s): Allan M. Lowe, Reg. No. 19.641; Benjamin J. Hauptman, Reg. No. 29,310; Israel Gopstein, Reg. No. 27,333; Kenneth M. Berner, Reg. No. 37,093; Michael G. Gilman, Reg. No. 19,114; and Randy Noranbrock, Reg. No. 42, 940, all of

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with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith, and all future correspondence should be addressed to them.

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ull name of sole or fire	st inventor: YOON, Jeong-Goo
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